



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Warren M. Farnworth

Serial No.: 10/074,840

Filed: February 13, 2002

For: STEREOLITHOGRAPHIC METHODS FOR FABRICATING HERMETIC SEMICONDUCTOR DEVICE PACKAGES AND SEMICONDUCTOR **DEVICES INCLUDING**

STEREOLITHOGRAPHICALLY **FABRICATED HERMETIC PACKAGES**

Confirmation No.: 8060

Examiner: D. Zarneke

Group Art Unit: 2827

Attorney Docket No.: 4212.3US (99-0306.3)

Notice of Allowance Mailed:

October 1, 2002

CERTIFICATE OF MAILING

312.0b).Wello2 (/24/62 I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail (under 37 C.F.R. § 1.8(a)) on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

December 16, 2002 Date of Deposit

Signature of registered practitioner or other person having reasonable basis to expect mailing to occur on date of deposit shown pursuant to 37 C.F.R. § 1.8(a)(1)(ii)

Amanda Holland

Typed/printed name of person whose signature is contained above

yntered J. Mcuullar Op1/03

#11/B Andt Att

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Box ISSUE FEE Commissioner for Patents Washington, D.C. 20231

Sir:

Please amend the above-referenced application as follows:

TECHNOLOGY CENTER 2800